

Design Policy and Strategy in the Expansion of Global Economic Initiatives

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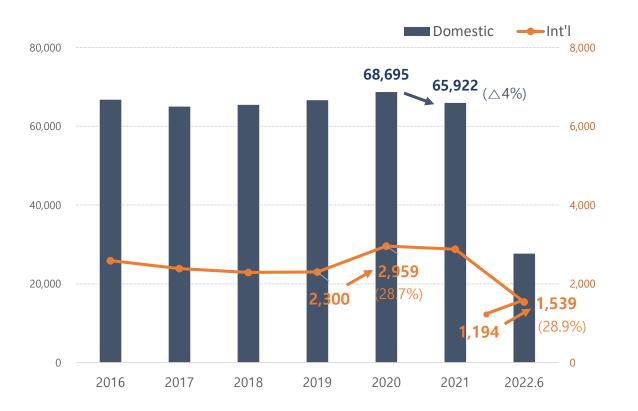
Current Status : Application, First office action pendency

Strategic Use of Industrial Design system in Korea

Current Status - Application

KIPO

KR Design Applications ('16~'22.6)



65,922 domestic applications in '21

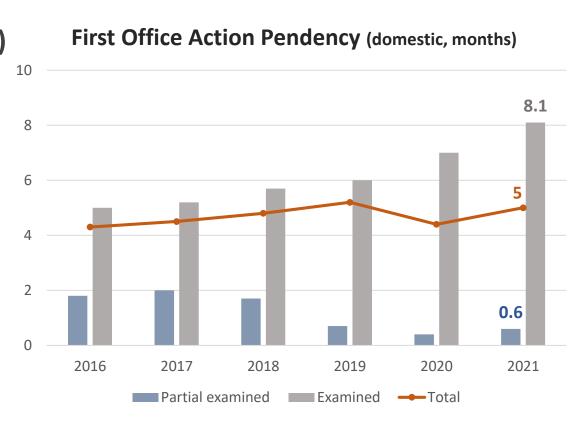
Increase in Int'l design (Hague) - '20: 28.7% over '19 - '22.6: 28.9% over '21.6

Current Status – First Office Action Pendency

Hybrid Examination System

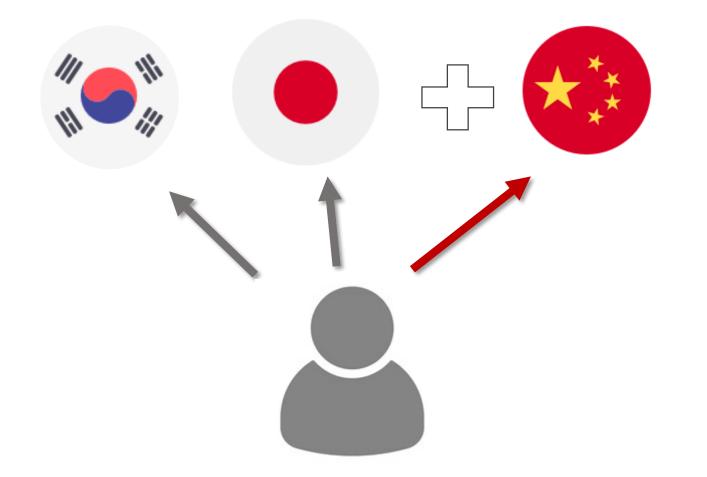
- : Partial Examined design (class 1,2,3,5,9,11 or 19)
- : Examined design (except the above)

- 0.6 months for partial examined design8.1 months for examined design
 - → 5.0 months for First OA in general

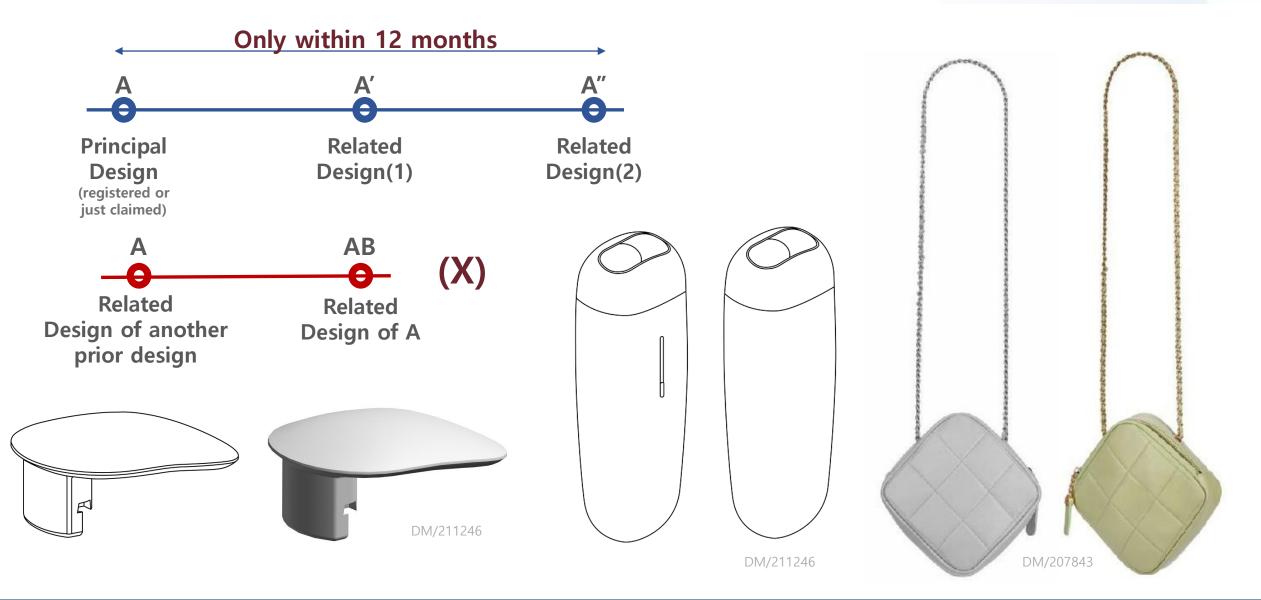


Strategic Use of ID System – for Hague Applicants





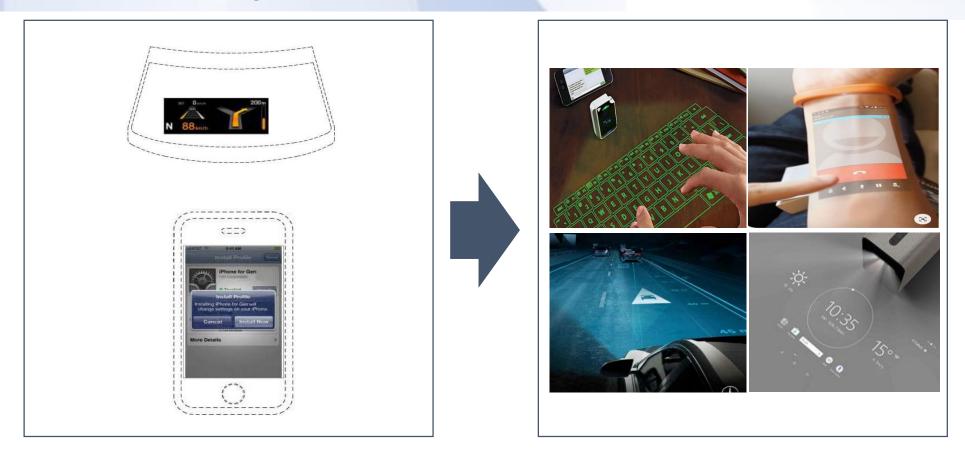
Strategic Use of ID System – related design



KIPO



Strategic Use of ID System – graphic image design



Imited to those used to operate the device or displayed as a result of the device performing its function

Strategic Use of ID System – partial design



Indication of product



Drawing : broken lines, color, etc.







Strategic Use of ID System – exception to lack of novelty

Within **12 months** before filing an application

All kinds of publication (except for a design the application or registration of which is **published** in the ROK or in a foreign country under a treaty or an Act)

- **1.** When filing an application
- 2. Before a notification of refusal or design registration
- When a person submits a written reply to an opposition to registration of a partially-examined design
- **4.** When a person submits a written reply to a petition for a trial on the invalidation of design registration

DM/1/II (E) WINDER DECIMANANCE Lesion System ANNEX II Supporting Document(s) Concerning a Declaration to the Exception to Lack of Novelty under Section 408(c)(ii) of the Administrative Instructions

IMPORTANT

- This Annex can be used to submit documents in support of a declaration concerning exception to lack of novelty to the China National Intellectual Property Administration (CNIPA), the Japan Patent Office (JPO) and/or the Korean Intellectual Property Office (KIPO) (refer to form DM/1, item 15).
- 2. Please note that a declaration concerning exception to lack of novelty might affect the applicant's rights in other jurisdictions. It is the responsibility of the applicant to ensure that their rights are preserved.
- 3. For detailed information on the procedure when designating Japan, please visit the JPO website
- 4. This Annex must be submitted with form DM/1 at the time of filing it cannot be submitted separate
- 5. Please number your pages.



THANK YOU!

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